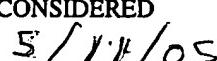
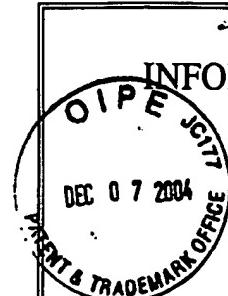


INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)		ATTY. DOCKET NO. 004066 USA/ Consilium/Consilium		SERIAL NO. 09/363,966	
				RECEIVED OCT 14 2004 Technology Center 2100	
				APPLICANT John F. ARACKAPARAMBIL et al.	
				FILING DATE July 29, 1999	
				GROUP 2125	
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EXAMINER		DATE CONSIDERED			
<i>Charles</i>		<i>5/11/05</i>			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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		FILING DATE July 29, 1999	GROUP 2125
OTHER ART: (Including Author, Title, Date, Pertinent Pages, Etc.)			
Snb	IslamRaja, M. M., C. Chang, J. P. McVittie, M. A. Cappelli, and K. C. Saraswat. May/June 1993. "Two Precursor Model for Low-Pressure Chemical Vapor Deposition of Silicon Dioxide from Tetraethylorthosilicate." <i>J. Vac. Sci. Technol. B</i> , Vol. 11, No. 3, pp. 720-726.		
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EXAMINER 			
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INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(PTO-1449)

**ATTY. DOCKET NO.
004066 USA/
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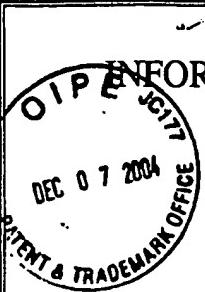
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APPLICANT

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APPLICANT John F. ARACKAPARAMBIL et al.			
FILING DATE July 29, 1999	GROUP 2125		
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)			
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EXAMINER <i>Gardel</i>	DATE CONSIDERED <i>5/14/05</i>		

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